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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Volker Derflinger et al.
Serial No.: 10/825,504 Art Unit: 3722
Filing Date: April 15, 2004
Title: WORKPIECE WITH A HARD FILM OF AlCr-
CONTAINING MATERIAL, AND PROCESS FOR ITS
PRODUCTION
Docket No.: 35523US1

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

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Sir/Madam:

In accordance with Rule 56, applicants are aware of the publications listed in the International Search Report (copy enclosed) and in the enclosed copy of Patent Office Form 1449. A copy of each of the foreign references and articles is enclosed herewith. Since this Form 1449 is being filed as part of a U.S. Patent Application filed after June 30, 2003, a copy of each of the publications is not enclosed in accordance with the Patent Office waiver of 37 CFR 1.98(a)(2)(i).

If there are any fees resulting from this communication, please charge same to our Deposit Account No. 16-0820, Order No. 35523US1.

Respectfully submitted,

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October 12, 2005

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Michael W. Garvey

10/12/2005

Name of Attorney

Signature of Attorney

Date

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35523US1SERIAL NO.
10/825,504


INFORMATION DISCLOSURE CITATION
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APPLICANT:
Volker Derflinger et al.FILING DATE:
April 15, 2004GROUP ART UNIT:
3722

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date If Appropriate
	A	2003/0035894 A1	02/2003	Derflinger et al.			
	B						
	C						
	D						
	E						
	F						
	G						
	H						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	I	10-25566	01/1998	Japan			English Abstract
	J	9-41127	02/1997	Japan			English Abstract
	K	1 422 311 A2	11/2003	Europe			English Text
	L	1 422 311 A3	11/2003	Europe			English Abstract

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	M	F. Sanchette, A. Billard, C. Frantz, "Mechanically reinforced and corrosion-resistant sputtered amorphous aluminium alloy-coatings", Surface and Coatings Technology 98 (1998), pages 1162-1168.
	N	J. Vetter, E. Lugscheider, S.S. Guerreiro, "(Cr:Al) N Coatings deposited by the cathode vacuum arc evaporation", Surface and Coatings Technology 98 (1998), pages 1233-1239.
	O	Clemens Kunisch, Ronald Loos, Michael Stuber and Sven Ulrich, "Thermodynamic modeling of Al-Cr-N thin film systems grown by PVD", 1999, pages 847-852.
	P	Y. Ide, T. Nakamura and K. Kishitake, "Formation of Al-Cr-N films by a DC reactive sputtering method and evaluation of their properties", 2000, pages 291-296.

Examiner:

Date Considered

*Examiner: Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.